

<b>PTO-1449</b> <b>Information Disclosure Citation</b> <b>In an Application</b>	Application No. <b>09/853,319</b>	Applicant(s) <b>Hiroshi (nmi) Onaka</b>
	Docket Number <b>064731.0188</b>	Group Art Unit <b>2633</b>

**U.S. PATENT DOCUMENTS**

	<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
A						
B						
C						
D						
E						
F						
G						
H						
I						
J						
K						
L						
M						

**RECEIVED**

SEP 17 2004

Technology Center 2600

**FOREIGN PATENT DOCUMENTS**

	<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>
N						YES NO

**DOCUMENT (Including Author, Title, Source, and Pertinent Pages)****DATE**

O	Walid A. Atia et al., "Demonstration of Return-to-Zero Signaling in both OOK and DPSK Formats to Improve Receiver Sensitivity in an Optically Preamplified Receiver," Lasers and Electro-Optics Society 1999 12th Annual Meeting, LEOS 1999, IEEE, Volume 1, 8-11, Pages 226-227, Volume 1, 2 pages	1999
P		
Q		
R		

EXAMINER

SL-K-L

DATE CONSIDERED

1/19/2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

PTO-1449	Application No. 09/853,319	Applicant(s) Hiroshi (nmi) Onaka	
Information Disclosure Citation In an Application	Docket Number 064731.0188	Group Art Unit 2633	Filing Date May 10, 2001
U.S. PATENT DOCUMENTS			



	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
sh	A 4,794,351	12/27/1988	Darcie	332	7.51	09/29/1986
sh	B 5,515,196	05/07/1996	Kitajima et al.	359	180	04/02/1993
sh	C 5,907,421	05/25/1999	Warren et al.	359	180	03/20/1996
sh	D 6,005,702	12/21/1999	Suzuki et al.	359	183	02/19/1997
sh	E 6,058,147	05/02/2000	Eklof et al.	375	344	03/03/1997
sh	F 6,163,394	12/19/2000	Webb	359	181	02/12/1998
sh	G 6,323,993 B1	11/27/2001	Hansen et al.	359	337	02/19/1999
sh	H 6,341,023 B1	01/22/2002	Puc	359	124	07/23/1999
sh	I 6,407,845 B2	06/18/2002	Nakamoto	359	239	02/22/2001
sh	J 6,417,958 B1	07/09/2002	Du et al.	359	334	01/24/2001
sh	K 6,459,515 B1	10/01/2002	Bergano	359	124	03/12/1999
sh	L 6,549,311 B1	04/15/2003	Hakki et al.	359	124	07/14/1999
sh	M 6,556,326 B2	04/29/2003	Bergano	359	181	01/17/2001

## FOREIGN PATENT DOCUMENTS

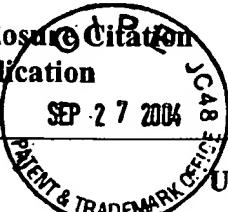
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
sh	N JP02000059300A	02/25/2000	Japan	H04B	G01B	X	

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
sh	O Takato, et al., "Silica-Based Integrated Optic Mach-Zehnder Multi/Demultiplexer Family with Channel Spacing of 0.01-250 nm", IEEE Journal on Selected Areas in Communications, Vol. 8, No. 6, pp 1120-1127	08/1990
P		
Q		
R		
S		
T		
U		

EXAMINER	sh k-6	DATE CONSIDERED	1/9/2005
----------	--------	-----------------	----------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

PTO-1449 <b>Information Disclosure Citation In an Application</b> SEP 27 2004		Application No. 09/853,319	Applicant(s) Hiroshi (nmi) Onaka	
		Docket Number 064731.0188	Group Art Unit 2633	Filing Date May 10, 2001



## U.S. PATENT DOCUMENTS

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
sh	V	6,556,327 B1	04/29/2003	Ohya et al.	359	183	11/05/1998
sh	W	6,616,353 B1	09/09/2003	Helkey	398	183	10/07/1999
sh	X	6,618,352 B1	09/09/2003	Shirakata et al.	370	203	05/25/1999
	Y						
	Z						
	AA						
	BB						<b>RECEIVED</b>
	CC						SEP 30 2004
	DD						
	EE						
	FF						
	GG						
	HH						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	II							

## DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

DATE

JJ		
KK		
LL		
MM		
NN		
OO		
PP		

EXAMINER

Shi K. L.

DATE CONSIDERED

1/19/2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

U.S. PATENT AND TRADEMARK OFFICE